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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 9191
Makoto AKIZUKI et al. : Docket No. 2001-1897
Serial No. 10/025,899 : Group Art Unit 1762
Filed December 26, 2001 : Examiner Bernard D. Pianalto

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TC 1700

METHOD FOR FORMING GAS CLUSTER AND
METHOD FOR FORMING THIN FILM

PATENT OFFICE FEE TRANSMITTAL FORM

Commissioner for Patents
P.O. Box 1450
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Sir:

Attached hereto is a check in the amount of \$930.00 to cover Patent Office fees relating to filing the following attached papers:

Petition for Extension of Time \$930.00

A duplicate copy of this paper is being submitted for use in the Accounting Division, Office of Finance.

The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.

Respectfully submitted,

Makoto AKIZUKI et al.

By Matthew Jacob
Matthew Jacob
Registration No. 25,154
Attorney for Applicants

MJ/krl
WENDEROTH, LIND & PONACK, L.L.P.
2033 K St., N.W., Suite 800
Washington, D.C. 20006-1021
Telephone (202) 721-8200
August 27, 2003

[Check No. 57357]

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